

Ion Induced Desorption Measurements at GSI

- Motivation

ion-beam loss induced desorption and its consequences for the SIS18 upgrade

- HLI Experiments @ 1.4 MeV/u

desorption yields for C^{2+} , Cr^{7+} , Zn^{10+} and Pb^{27+} on diff. targets

- SIS Experiments @ 15-1000 MeV/u

preliminary desorption yields for U^{73+} on diff. targets

- planned ERDA Experiments

method of Elastic Recoil ion Detection Analysis

and its application for ion-induced desorption measurements

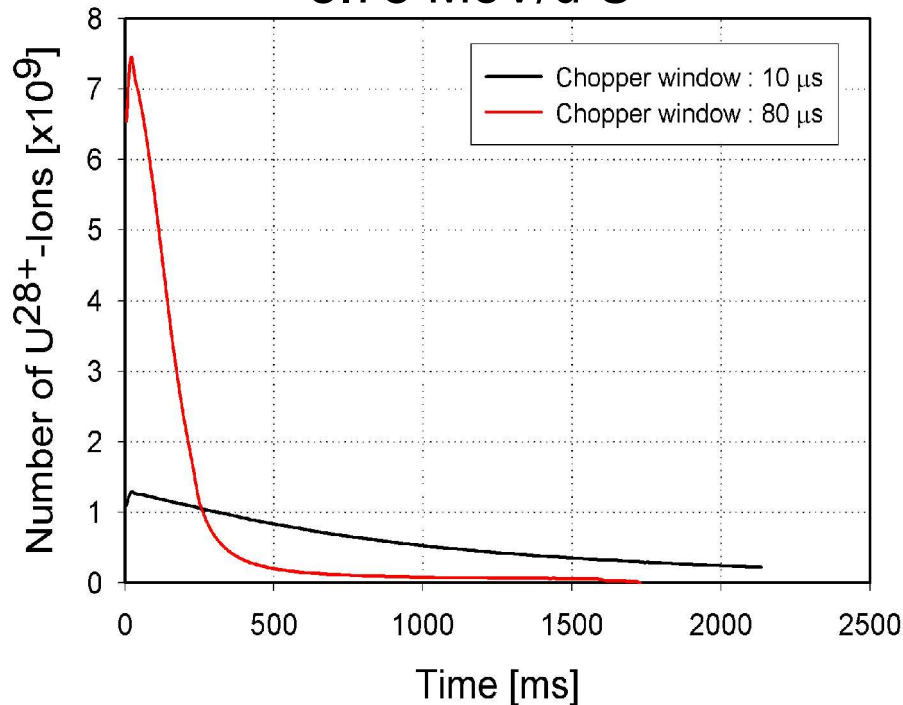
M. Bender, A. Kraemer, M.C. Bellachioma and H.K. (GSI)

E. Mahner (CERN)

Dynamic Vacuum and Beam Lifetime

P. Spiller, December 2001

8.75 MeV/u U^{28+}



Desorption processes degenerate the residual gas pressure.

Initiated by:

Systematic beam losses on acceptance limiting devices (septa)

Stripped beam ions

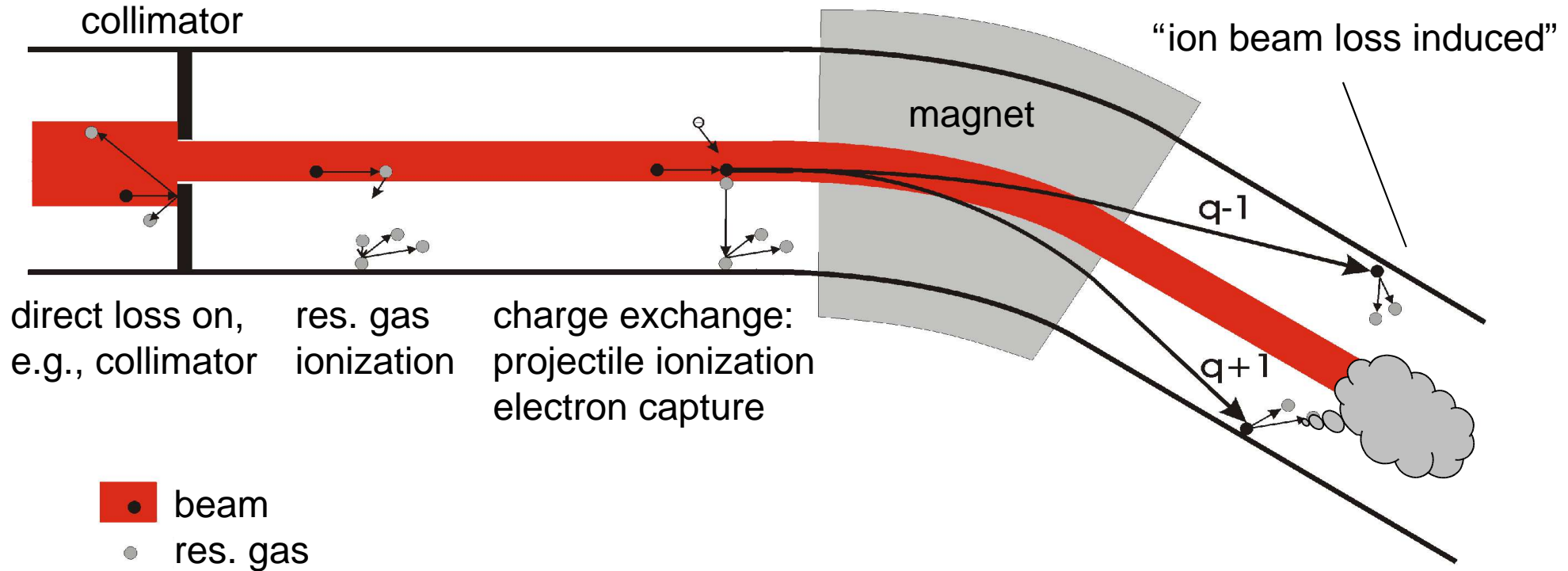
Ionized and accelerated residual gas

Beam losses increase with number of injected ions

-> "show stopper" for GSI future facility FAIR (10^{12} ion/s from SIS18)

Beam Loss Processes

“ion beam loss induced” ($\sim 10^4$) “ion induced” ($\sim 1-10$)

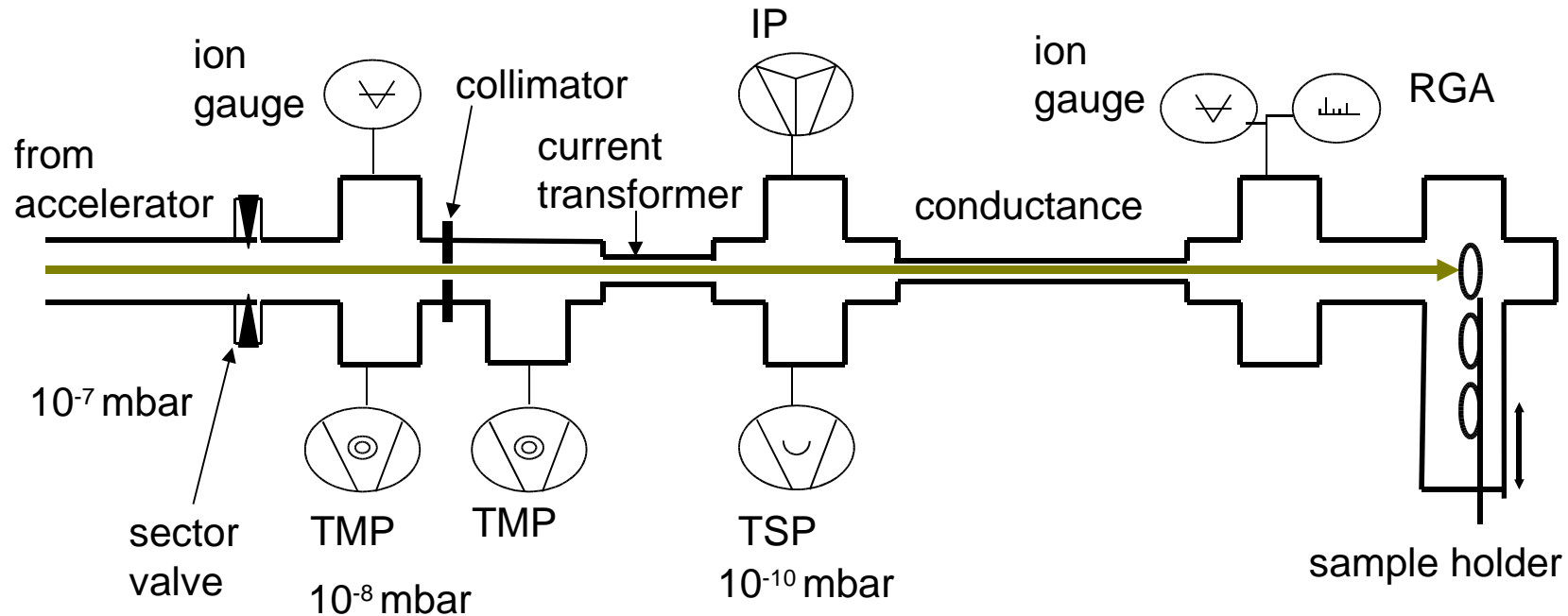


desorption coefficient

$$\eta = \frac{\text{molecules (atoms)}}{\text{ion}}$$

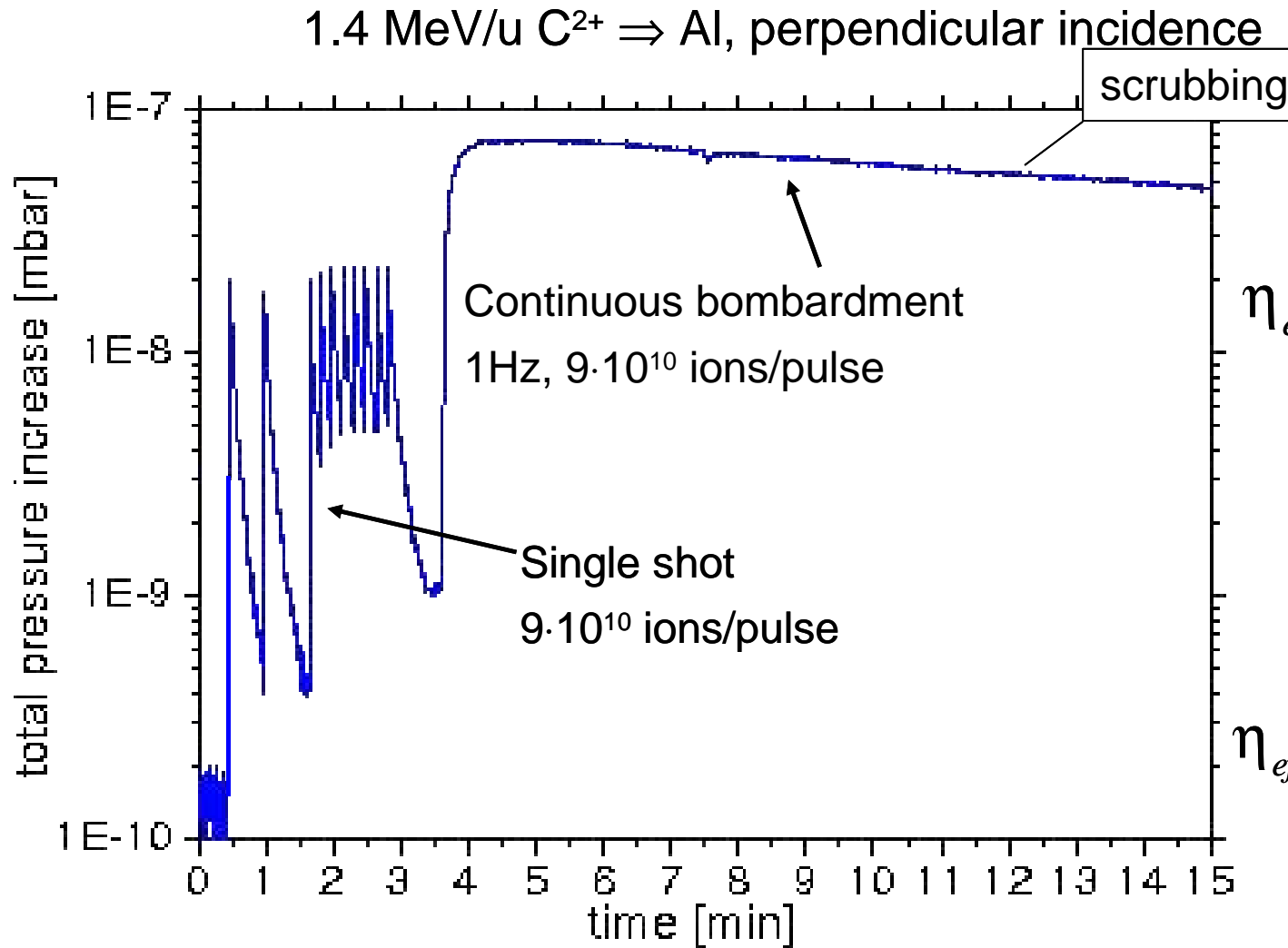
$$\eta = \eta(M, E, Z, T, \varphi, \dots)$$

Experimental Setup for Ion Beam Induced Desorption Yield Measurements



Experiments by:
M. Bender (GSI)
H. Kollmus (GSI)
A. Krämer (GSI)
E. Mahner (CERN)

Total Pressure Increase due to Desorption



Single shot

$$\eta_{eff} = \frac{\Delta p \times V}{N_{ion} \times k_B \times T}$$

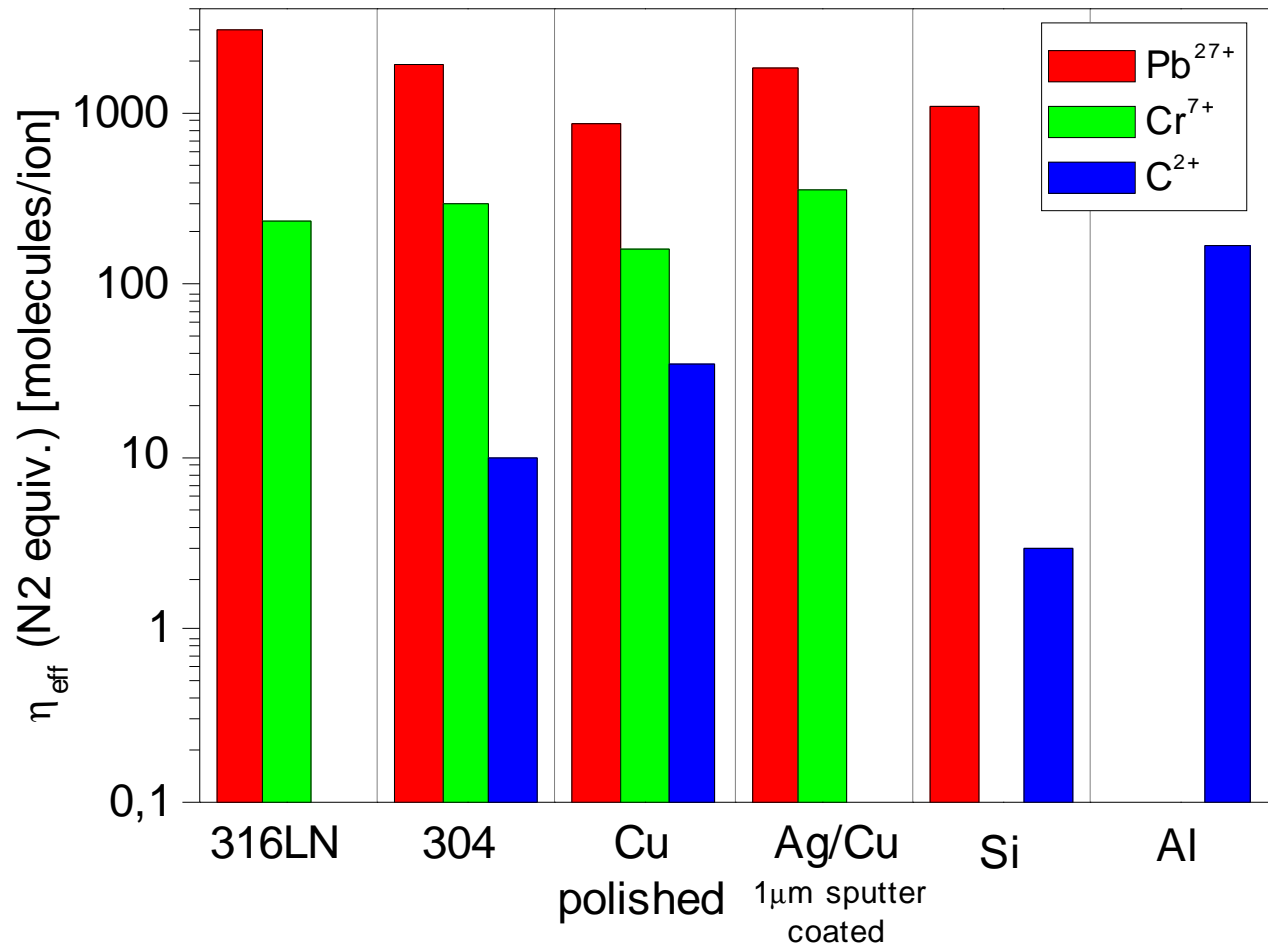
(conductance)

Continuous bombardment

$$\eta_{eff} = \frac{\Delta p \times S}{\dot{N}_{ion} \times k_B \times T}$$

Single Shot Results of Desorption Yield Measurements at GSI

Energy: 1.4 MeV/u, Intensities: $10^9 - 10^{11}$ ions per pulse, perpendicular incidence
desorption yield η between 3 and 3000

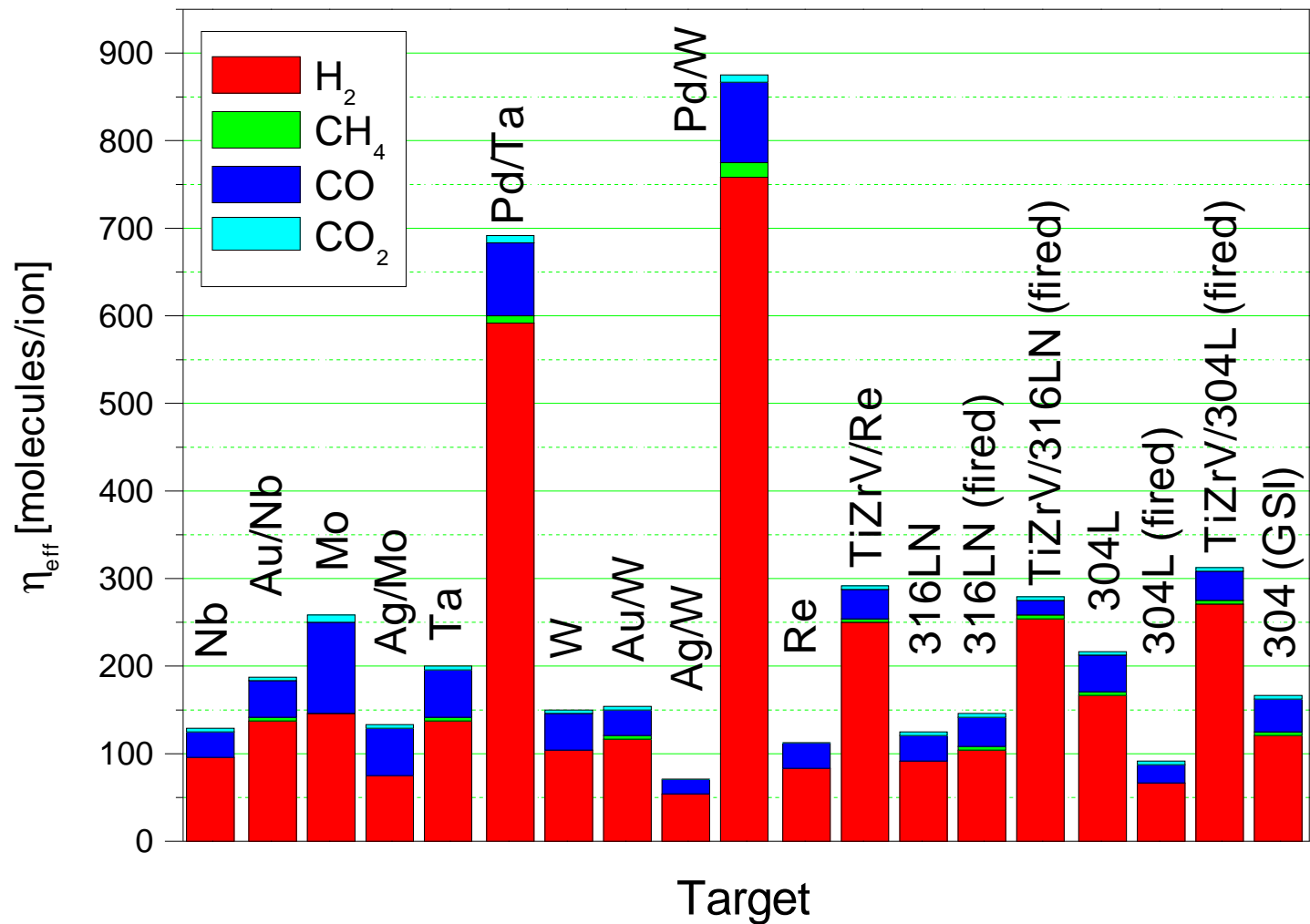


The calculated desorption yields are not corrected for the "real" gas composition, which is H₂ dominated. Therefore the desorption yields are underestimated by a factor of about 2.

η scales with mass and charge state

Desorption Yields Calculated from Scrubbing Plots by E. Mahner (CERN)

1.4MeV/u Zn¹⁰⁺



Mainly desorbed gases are H₂ and CO.

targets provided by



SIS18 Desorption Teststand

September 2004:

First test-experiment to measure ion beam induced desorption yields of U^{73+} at energies from 15 to 1000 MeV/u bombarding stainless steel 316LN, stainless steel P506, Al, Cu and Inconel625

Schematic Drawing of Experimental Setup

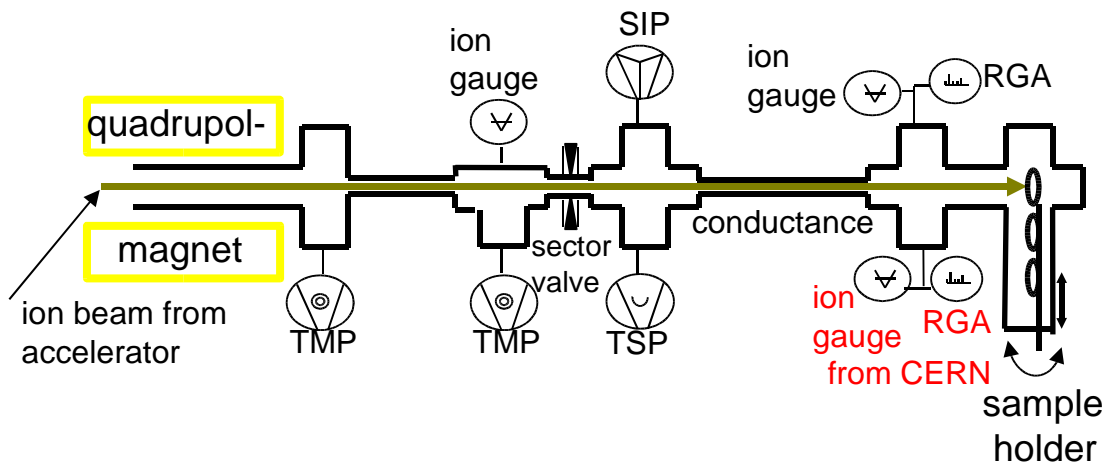
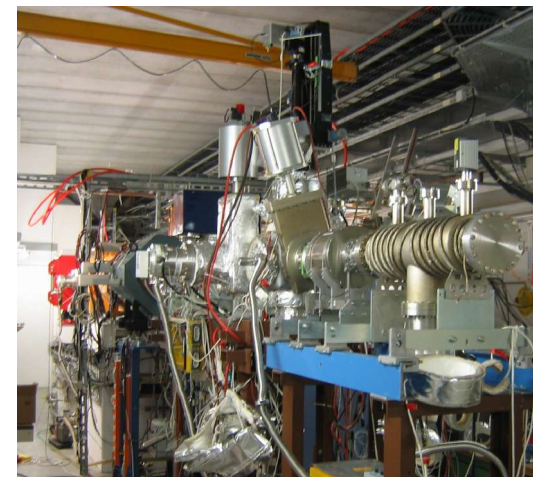


Photo of Experiment at Cave HHT



Target Holder



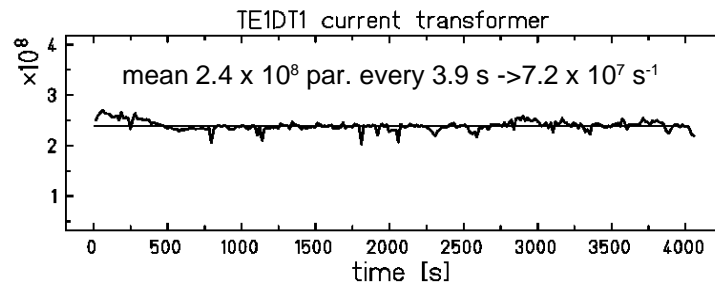
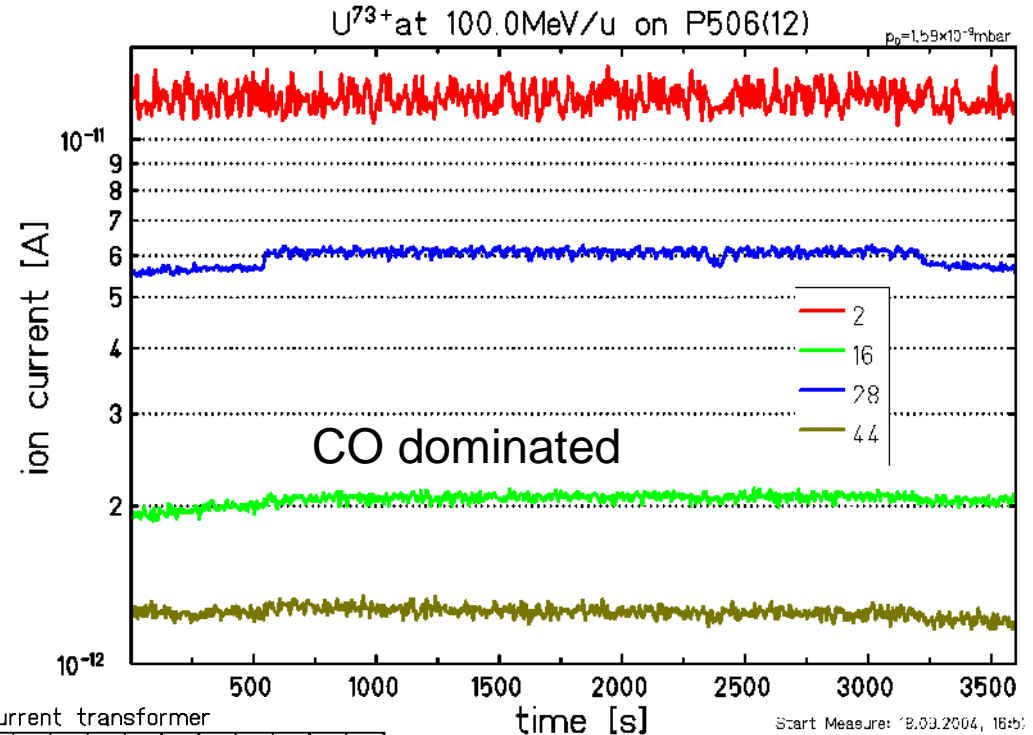
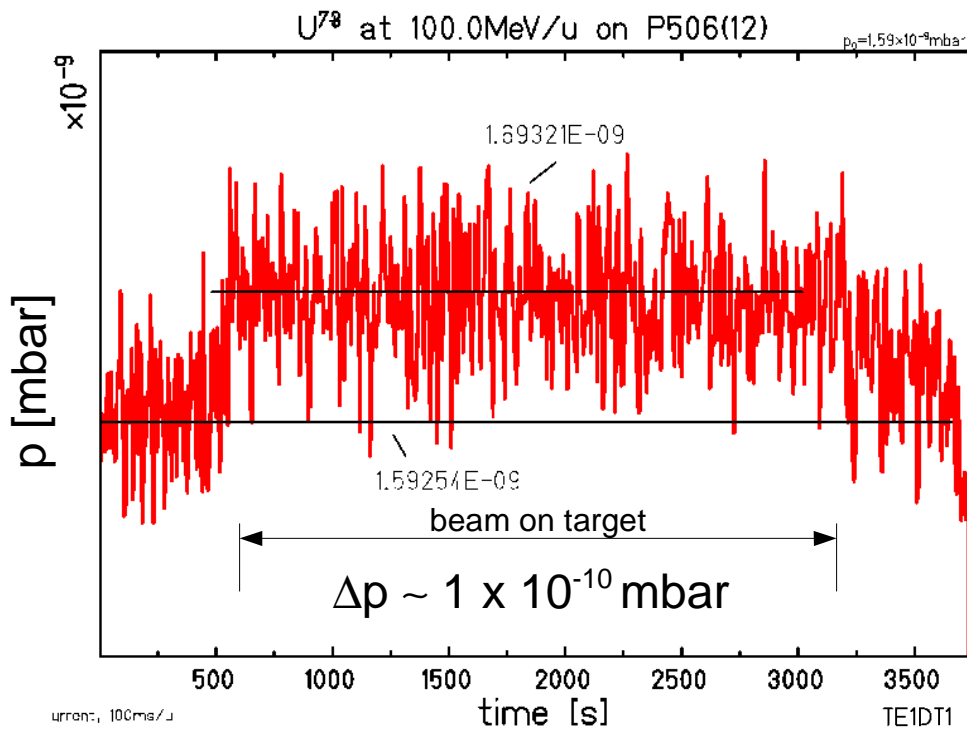
Experiment by: M.C. Bellachioma, M. Bender, H. Kollmus, A. Krämer (GSI), E. Mahner (CERN), O. Malyshev (ASTeC; UK), L. Westerberg, E. Hedlund (TSL; Sweden)

SIS Experiment

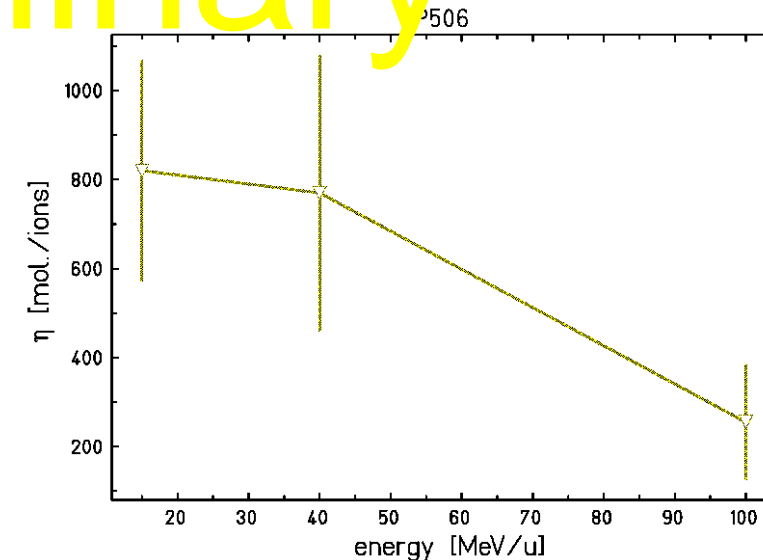
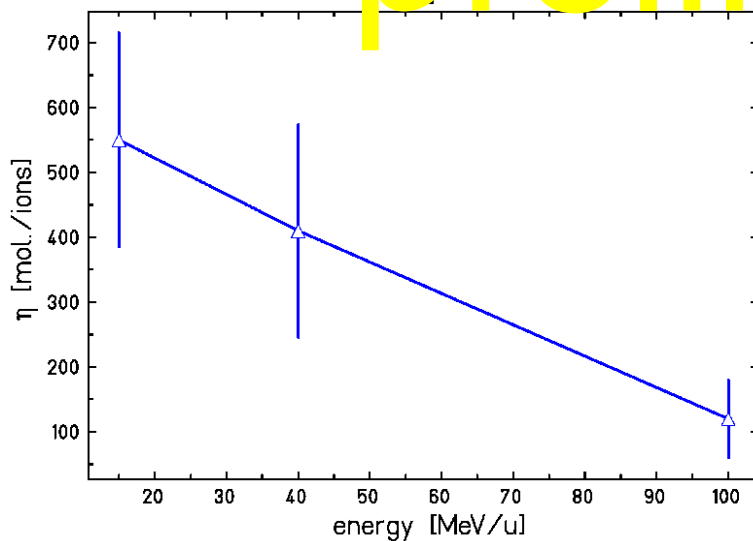
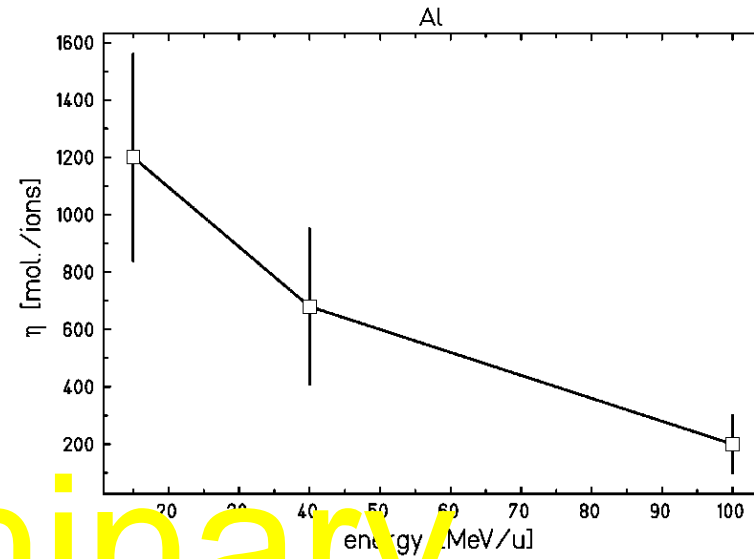
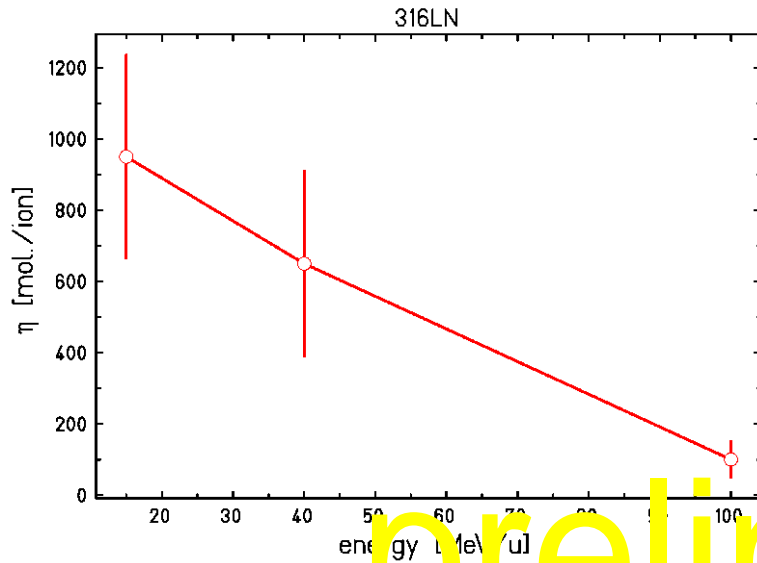
15, 40, 100, 408, 1000 MeV/u U^{73+} -> 316LN, Al, Cu, Inconel625, P506 (Boehler stainless steel)
 number of ions $\sim 5 \times 10^7 \text{ s}^{-1}$

total pressure (N_2 equivalent)

res. gas distribution (ion current)



Yield vs. Energy – SIS Measurements

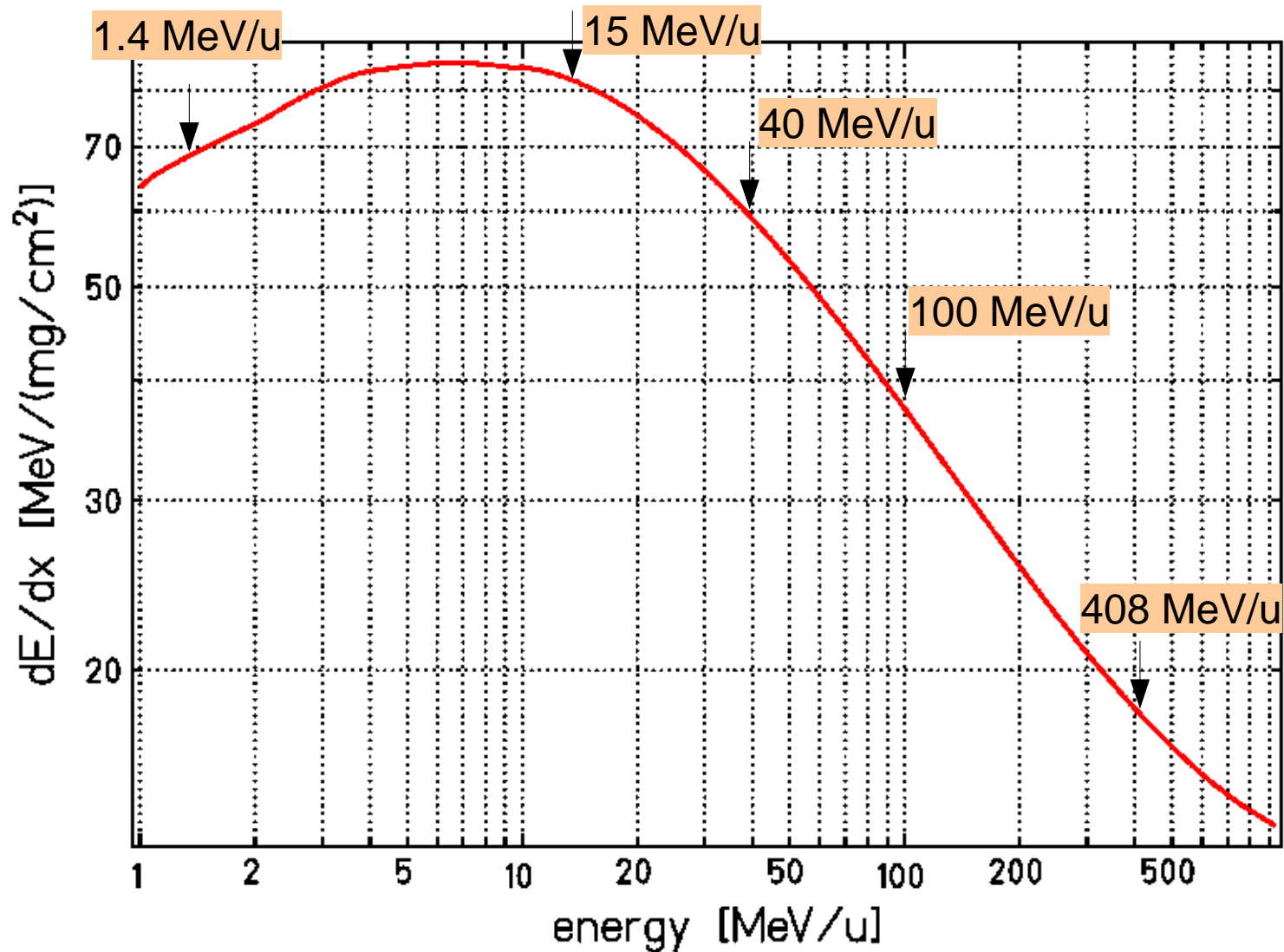


preliminary

no gaugeable pressure rise for 408 and 1000 MeV/u U^{73+} on 316LN (η less then 100)

Electronic Energy Loss

U -> stainless steel, calculated using the TRIM code



Outlook

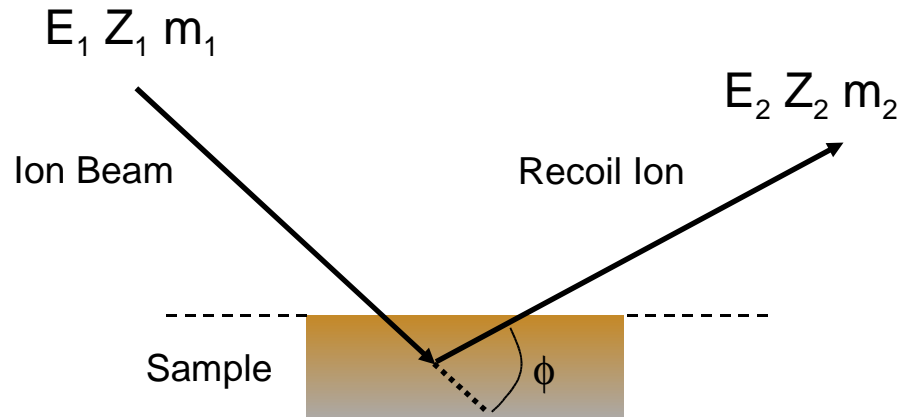
- Desorption measurements were performed for a multiplicity of projectile charge states and energies, scaling with mass was observed
- preliminary energy dependence for U^{73+} measured – dE/dx scaling

todo:

- repetition of energy dependence measurements
- charge state dependency? (not expected - equilibrium q)
- angle dependency of desorption yield – depth of energy loss test of dE/dx
- desorption yields of cold surfaces (with condensed gases)

- ERDA-Measurements – understanding of the physics behind the ion-induced desorption

Elastic Recoil Ion Detection Analysis (ERDA)



- same sensitivity for all elements
- Z_1^4 dependence ($m=2Z$)
- depth profile easy accessible

Rutherford-Scattering:

$$\frac{E_2}{m_2} = \frac{4 \cos^2 \phi}{(1 + m_2 / m_1)^2} \frac{E_1}{m_1}$$

ERDA-Cross Section:

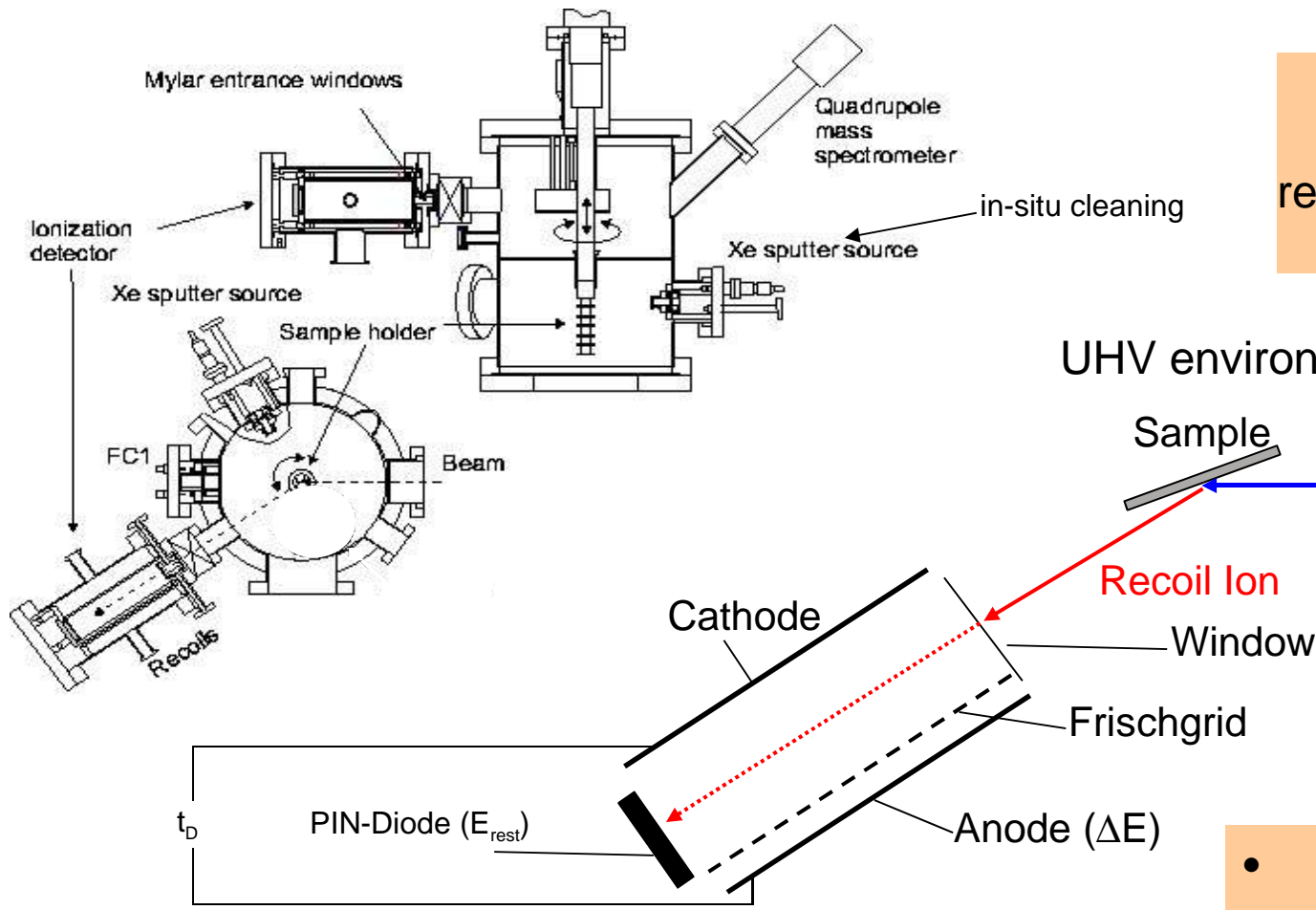
$$\sigma_{ERD} = \left(\frac{Z_1 Z_2 e^2}{2E_1} \right)^2 \left(\frac{m_1 + m_2}{m_2} \right)^2 \cos^{-3} \phi$$

for heavy ions: $m_2/m_1 \ll 1$

→ all recoil ions have approx the same velocity v (→ similar energy loss)

Experimental Setup for ERDA Measurement

set-up installed at
HLI of GSI
ready for commissioning
PhD Markus Bender



UHV environment

Sample Ion Beam

Recoil Ion

Cathode

Window

Frischgrid

Anode (ΔE)

PIN-Diode (E_{rest})

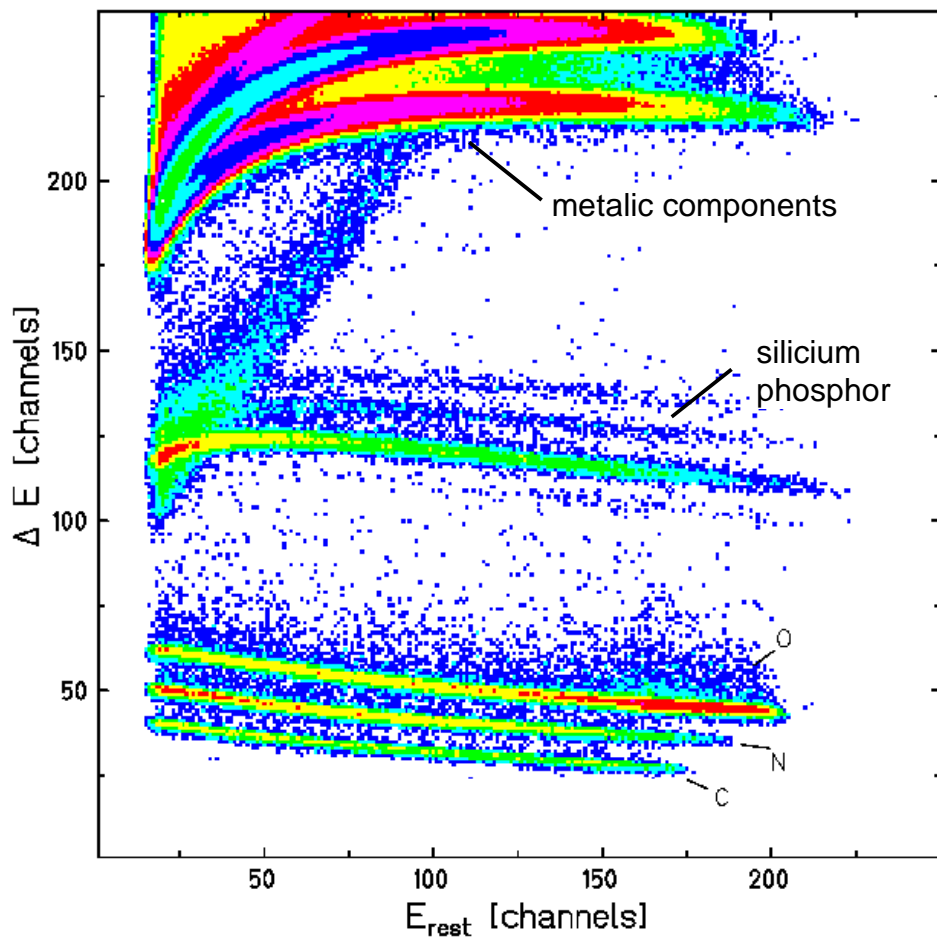
t_D

- ΔE : Element (Z)
- E_{rest} : Depth
- t_D : Emission Angle (ϕ)

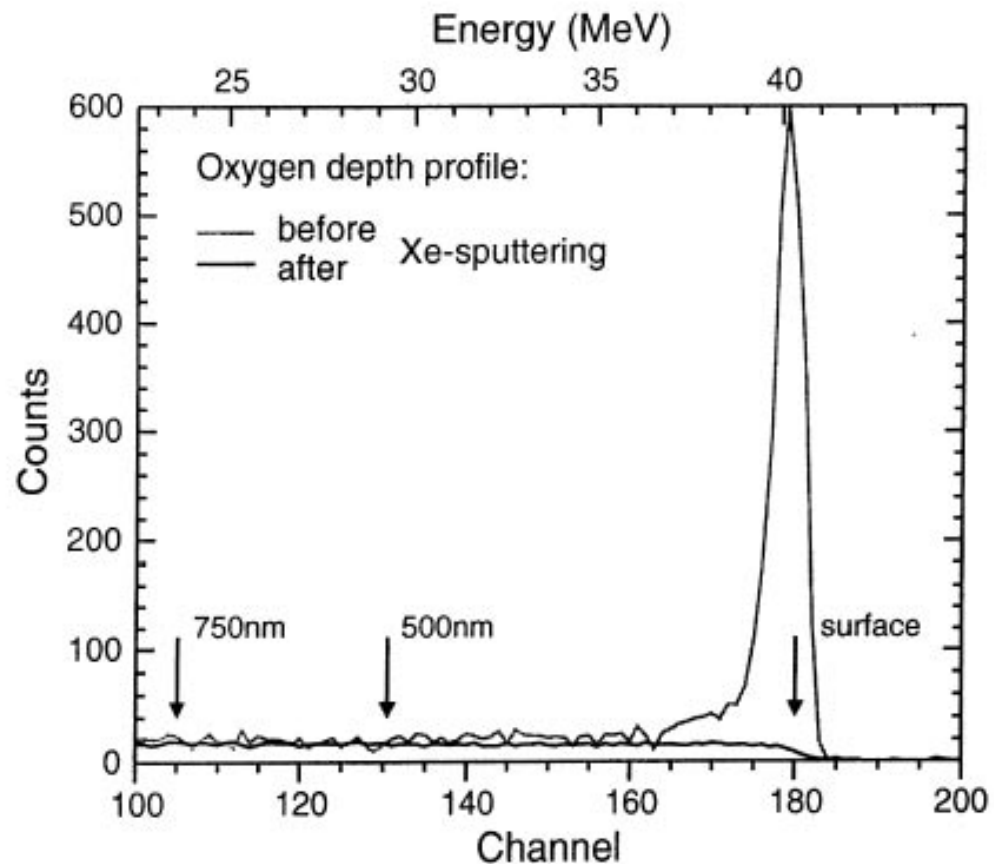
H. D. Mieskes et al., Measuring sputtering yields of high energy heavy ions on metals, NIM B 146 (1998)

ERDA-Spectra

1 MeV/u Au^{<30+>} → 304 L stainless steel

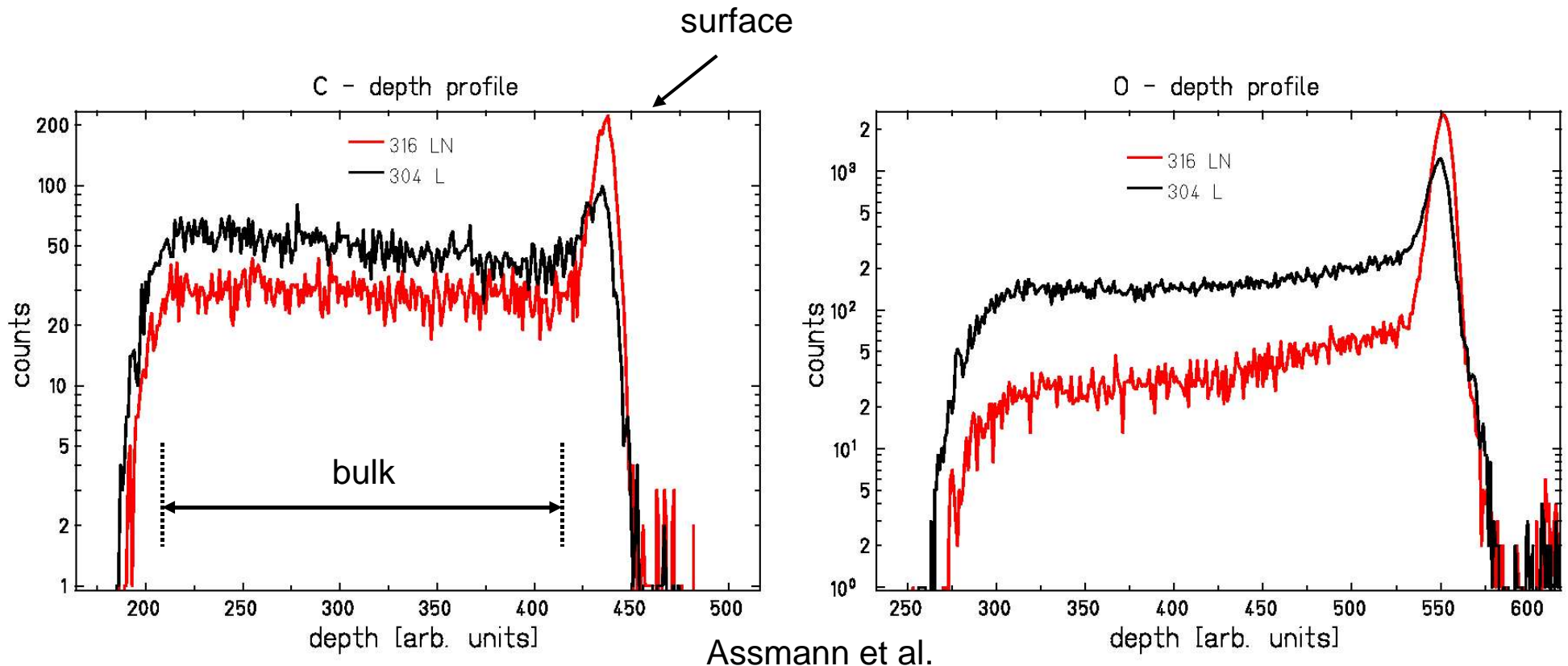


in-situ ERD energy profile of O-contamination in a *Ti* - sample



H. D. Mieskes et al., NIM B 146 (1998)

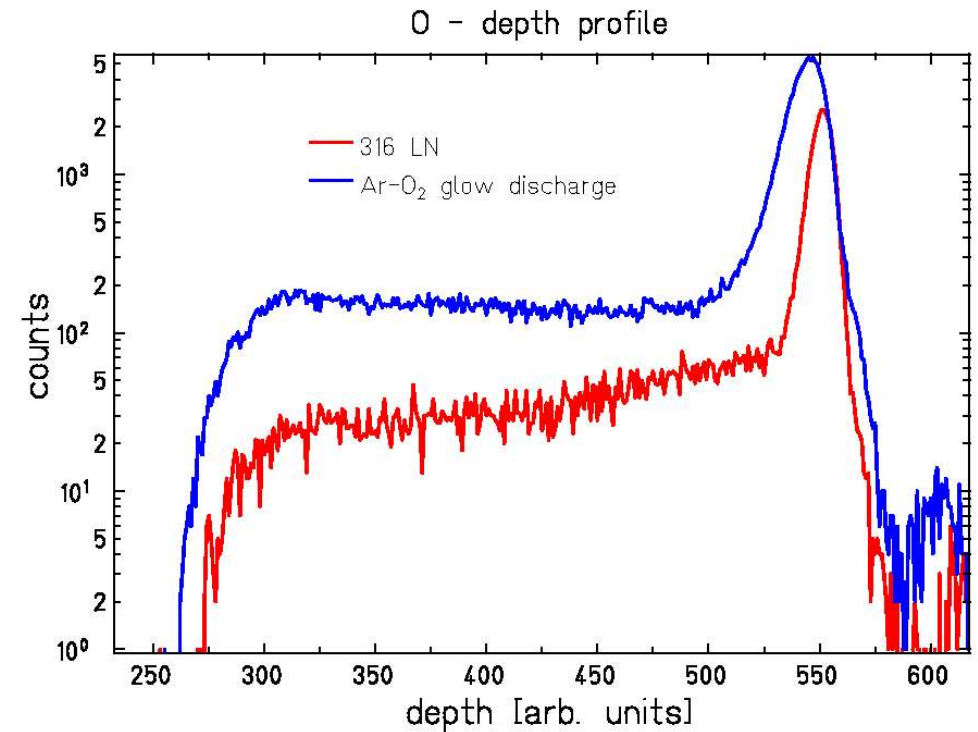
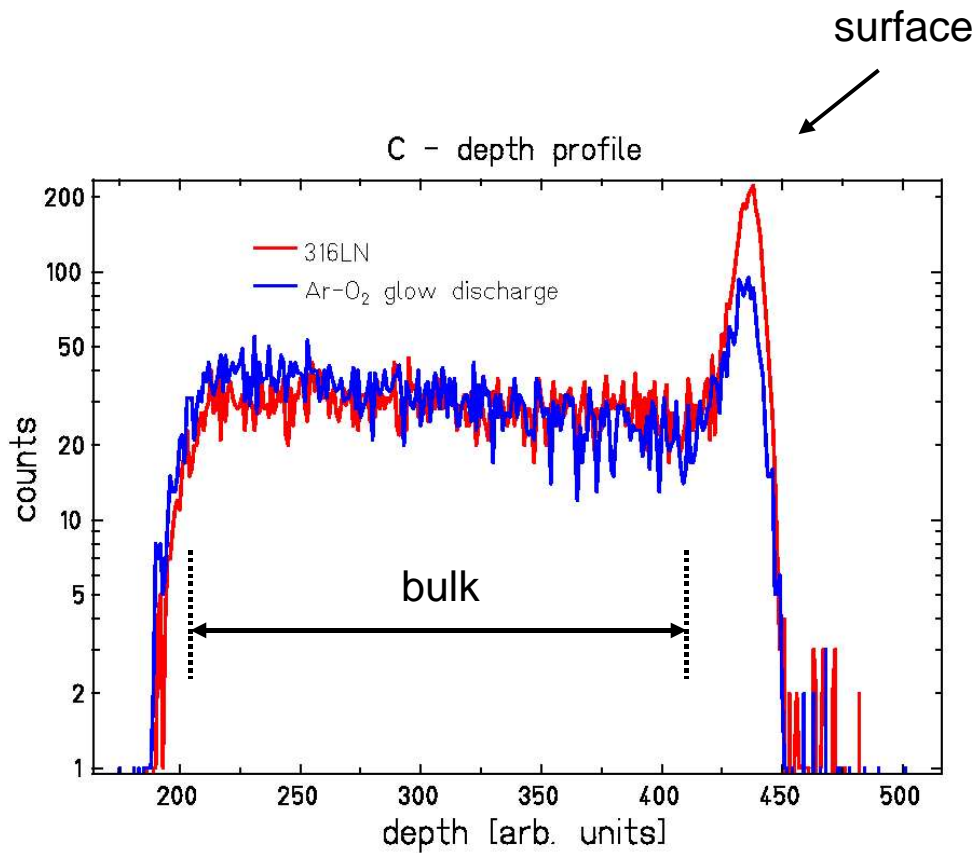
ERDA of Stainless Steel Samples



- the desorption yield of 316 LN was measured to be higher than the one of 304 L (Mahner et al.)
- all samples were exposed to atmosphere
- the ERDA measurements were performed in 1×10^{-7} mbar region

samples provided by E. Mahner (CERN)

ERDA of Stainless Steel Samples (2)



- the desorption yield of 316 LN – Ar-O₂ glow discharge was measured to be higher compared to the untreated 316 LN (Mahner et al., Phys. Rev. ST-AB6, 013201 (2003))

Outlook ERDA

- *in-situ* cleaning of targets with a sputter gun
- modifications of the target characteristics under ion bombardment
- correlations between target properties and desorption yields
- clear distinction between surface and bulk effects

planned experiments:

- influence of the oxide layer on the desorption yield
- desorption yield of single crystals monitored with ERDA
- desorption of “fancy“ target, like multiple layered targets with diffusion barriers
- measurement of electronic desorption yields